



Shibib 41-10

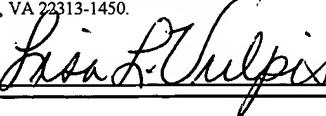
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Applicant(s): M.A. Shibib et al.
Case: 41-10
Serial No.: 10/719,195
Filing Date: November 21, 2003
Group: To Be Assigned
Examiner: To Be Assigned

Title: Metal-Oxide-Semiconductor Device
Formed in Silicon-On-Insulator

I hereby certify that this paper is being deposited on this date with the U.S. Postal Service as first class mail addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature:  Date: February 19, 2004

TRANSMITTAL OF FORMAL DRAWINGS

Mail Stop PGPUB Drawings
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attention: Official Draftsperson

Sir:

Applicants submit herewith three (3) sheets of formal drawings in the above-referenced application.

Respectfully submitted,



Wayne L. Ellenbogen
Reg. No. 43,602
Ryan, Mason & Lewis, LLP
Attorney for Applicant(s)
90 Forest Avenue
Locust Valley, NY 11560
(516) 759-7662

Date: February 19, 2004